



Docket No. 60040-0015

AMENDMENT UNDER 37 C.F.R. § 1.111

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Christopher HERTZLER, et al.	)	Confirmation No.: 4676
		)	
Serial No.:	09/846,495	)	Examiner: Hien Thi TRAN
		)	
Filing Date:	April 30, 2001	)	Art Unit: 1764

For: TREATMENT SYSTEM FOR REMOVING HAZARDOUS SUBSTANCES FROM A  
SEMICONDUCTOR PROCESS WASTE GAS STREAM

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

This is in response to the Office Action mailed January 7, 2005, the shortened statutory period for which runs until April 7, 2005. Please reconsider the subject application based on the amendments and remarks indicated below.

**Amendments to the Claims** begin on page 2 of this paper.

**Amendments to the Drawings** begin on page 8 of this paper and include an attached replacement sheet.

**Remarks** begin on page 9 of this paper.

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